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CONFIRMATION NO. 1952

SERIAL NUMBER 09/964,648	FILING DATE 09/28/2001 RULE	CLASS 438	GROUP ART UNIT 2812	ATTORNEY DOCKET NO. 862.C2397
APPLICANTS Keiji Yoshimura, Tochigi, JAPAN; ** CONTINUING DATA ***** PONG R ** FOREIGN APPLICATIONS ***** JAPAN 2000/302162 10/02/2000 JAPAN 2001/089762 03/27/2001				
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 11/14/2001				
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Allowance Verified and Acknowledged <input checked="" type="checkbox"/> Examiner's Signature Initials		STATE OR COUNTRY JAPAN	SHEETS DRAWING 15	TOTAL CLAIMS 27
INDEPENDENT CLAIMS 10				
ADDRESS 05514				
TITLE Exposure apparatus, semiconductor device manufacturing method, exposure apparatus maintenance method and semiconductor manufacturing factory				
FILING FEE RECEIVED 1396	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	

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